

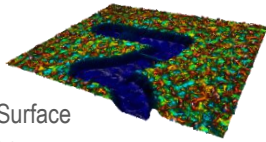
4-in-1 Technology Automatic Non-Contact 3D Surface Profiler

Technologies in 1 Surface Profiler



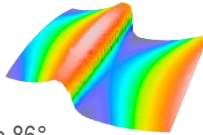
1) Confocal

Smooth to Rough Surface
Good XY Resolution



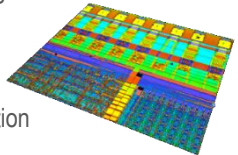
2) AI Focus Variation

High Slope Surface Up to 86°
High Speed Scanning

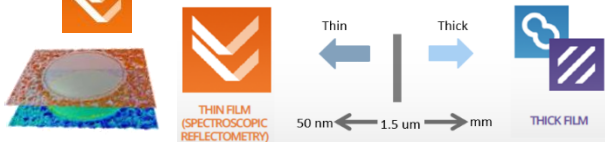


3) Interferometry

High Vertical Resolution
Z-Height Down to:
(0.1nm; 0.01nm Piezo)



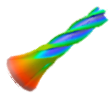
4) Thin Film Measurement



	AI FOCUS VARIATION	CONFOCAL	INTERFEROMETRY
Rough samples	★ ★ ★	★ ★ ★	★
Smooth samples	★	★ ★ ★	★ ★ ★ ★
Micro-scale features	★ ★	★ ★ ★	★ ★ ★ ★
Nano-scale features		★ ★	★ ★ ★ ★
High local slopes	★ ★ ★	★ ★	★
Thickness		★ ★ ★	★ ★ ★
Speed	★ ★ ★ ★	★ ★	★
Z resolution	★ ★	★ ★ ★	★ ★ ★ ★
XY resolution	★ ★	★ ★ ★	★ ★



Five Axis



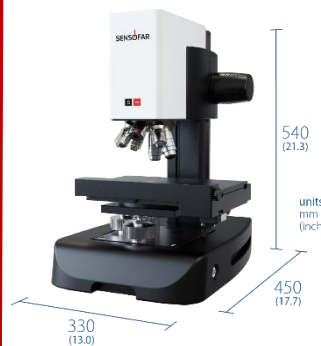
Optional 5-Axis Stage



S neox Semi-Automated Advance 3D Surface Profiler

- Automated multiple point scan & analysis feature available
- Customizable Motorized Stage Size & Jigs
- LED Light Source: Red, Green, Blue & White (True Colour Analysis)

****25x Times Longer Lifespan than Laser Source!**



- Basic profiler with blue & white LED light
- Motorized stage travel range 125 x 75mm
- Small & Compact for Labs
- Connects directly to Laptop/ PC
- Nanometric to Micrometric measurement
- Automatic analysis available



- Basic profiler with blue & white LED light
- Manual stage travel range 100 x 100mm
- Small, Compact & Affordable for Labs
- Connects directly to Laptop/ PC
- Nanometric to Micrometric measurement
- Automatic analysis available



S wide Fringe Projection (Semi-Automated)

- FOV Size: 34.7 x 29.1mm (Large area in Seconds)
- Automated scanning & analysis feature available
- Micrometric to Millimetric measurement

Spatial sampling ² (μm)	14.2
Optical resolution ³ (μm)	9.35
System noise ⁴ (μm)	< 1

Customized Full Automation Integration Solutions



- Integration with wafer robot handling system
- Integration with leadframe loader system
- Optional to be AGV ready
- Customizable motorized panel stage 700 x700 mm
- SECS/GEM

Software Automation

ACQUISITION



SensoSCAN
7

- Multiple Location Recipe Setting
- Fiducial Points Alignment
- User Friendly Interface

AUTOMATION & ANALYSIS



SensoPRO 3



SensoMATCH

- Auto-Analysis for Production
- Auto Pass / Fail Judgement
- Auto-Generated Reports
- Customized Analysis Parameters

ANALYSIS



SensoVIEW



SensoMAP



SensoCOMP

SensoView
Manual Analysis Operator & User Friendly

SensoMap
Advance Engineering Analysis

SensoCOMP
Forensic Comparison

-SDK Engineering Integration

SDK



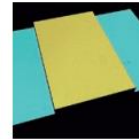
Sensor System



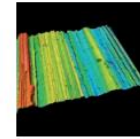
Applications with Customizable Auto Analysis



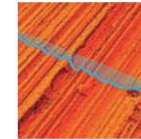
Step Height



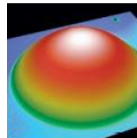
Step Height ISO



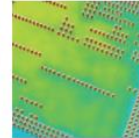
Surface Texture



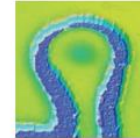
Surface Texture Profile



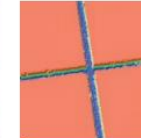
Aspheric



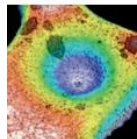
Bump



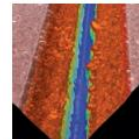
Circle Pad



Cross Kerf



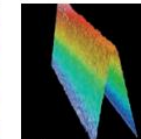
Dimple



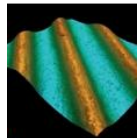
Double SH



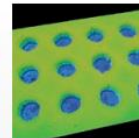
Dual Hole



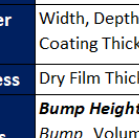
Edge



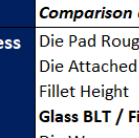
Wafer Probe



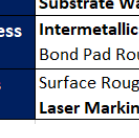
Wafer Laser Marking Process



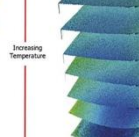
Wafer Saw/ Laser Groove/ Kerf



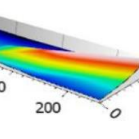
Laser Hole Process



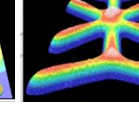
Wafer Level Bumping Process



Die Attach Process

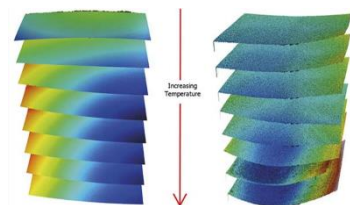


Wire Bond Process

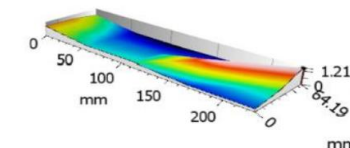


Molding Process

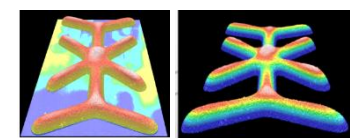
Wafer Probe	Probed Mark Depth Punched Through Hole
Wafer Laser Marking Process	Laser Marking Depth
Wafer Saw/ Laser Groove/ Kerf	Width, Depth, Laser Recast Measurement Coating Thickness on Transparent Glass
Laser Hole Process	Dry Film Thickness
Wafer Level Bumping Process	Bump Height, Diameter, Co-Planarity, Bump Volume Comparison of Probed & Non-Probed Bump
Die Attach Process	Die Pad Roughness Die Attached BLT, Tilt, Rotation & Offset Fillet Height Glass BLT / Fillet Height Die Warpage with Temperature & Time Change Solder Volume Substrate Warpage
Wire Bond Process	Intermetallic Coverage % Bond Pad Roughness, Cratering, Pad Remains
Molding Process	Surface Roughness Measurement Laser Marking Depth/ Roughness



4D Application:
Die Warpage with Temperature & Time



Substrate/Surface Warpage



Solder Volume